

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## In re Application of:

Warren M. Farnworth

Serial No.: 10/663,944

Filed: September 16, 2003

For: STEREOLITHOGRAPHIC METHOD FOR FORMING INSULATIVE COATINGS FOR VIA HOLES IN SEMICONDUCTOR

DEVICES (as amended)

Confirmation No.: 3861

Examiner: W. Brewster

Group Art Unit: 2823

Attorney Docket No.: 2269-5700US

(02-1183.00/US)

Notice of Allowance Mailed:

July 13, 2005

NOTICE OF EXPRESS MAILING

Express Mail Mailing Label Number: EL995992317US

Date of Deposit with USPS: October 10, 2005

Person making Deposit: Steve Wong

## AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

OK to enter. NB 16 NOVBS